



10824585 - GAU: 1792

PTO/SB/08A (10-01)

Approved for use through 10/31/2002. OMB 0651-0031

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				Application Number	10/824,585
				Filing Date	April 15, 2004
				First Named Inventor	Sung-Su JUNG et al.
				Art Unit	1792
				Examiner Name	David P. Turocy
Sheet	1	of	1	Attorney Docket Number	8734.291.00

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
	AA				
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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)				
	BA	WO 00/61297 A1	04-07-2000	Mydata Automation AB		
	BB	JP 2003-142816 A (w/Abstract)	05-16-2003	Fuji Mach Mfg. Co. Ltd.		
	BC	WO 02/099851 A2	05-31-2002	Litrex Corporation		
	BD	JP 09-122554 A (w/Abstract)	05-13-1997	Hitachi Techno Eng. Co. Ltd.		
	BE	JP 2003-177411 A (w/Abstract)	06-27-2003	Shibaura Mechatronics Corp.		
	BF					
	BG					
	BH					
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OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS			
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Examiner Signature	/David Turocy/	Date Considered	06/25/2009
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